



2823

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

JOZEF D. MITROS ET AL.

Serial No.. 10/020,034 (TI-32931)

Filed December 7, 2001

For: METHOD FOR FABRICATING LOW CHC
DEGRADATION MOSFET TRANSISTORS

Art Unit 2823

Examiner Long Pham

Customer No. 23494

Director of the United States
Patent and Trademark Office
P. O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING OR TRANSMISSION UNDER 37 CFR 1.8

I hereby certify that the attached document is being deposited with the United States Postal Service with sufficient postage for First Class Mail in an envelope addressed to Director of the United States Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450 or is being facsimile transmitted on the date indicated below:

2-2-04



Jay M. Cantor, Reg. No. 19,906

Sir:

AMENDMENT UNDER 37 C.F.R. 1.111

In response to the Office action dated December 17, 2003, please amend the
above identified application as follows: